

Electronic Patent Application Fee Transmittal

Application Number:	10529891			
Filing Date:	26-Jul-2005			
Title of Invention:	EXPOSURE MASK, METHOD OF DESIGNING AND MANUFACTURING THE SAME, EXPOSURE METHOD AND APPARATUS, PATTERN FORMING METHOD, AND DEVICE MANUFACTURING METHOD			
First Named Inventor/Applicant Name:	Takako Yamaguchi			
Filer:	Lawrence A. Stahl/elizabeth brugger			
Attorney Docket Number:	00684.003654.			
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U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
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Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
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Total in USD (\$)				1810